

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:	Wayne G. Renken		
Title:	Process Condition Sensing Wafer and Data Analysis System		
Application No.:	Not yet assigned	Filing Date:	October 14, 2003
Examiner:	Not yet assigned	Group Art Unit:	Not yet assigned
Docket No.:	SENS.005US1	Conf. No.:	Not yet assigned

Mail Stop Patent Application
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Dear Sir:

Please amend the above-identified divisional application with which this Preliminary Amendment is being filed, as follows: